

Application Data Sheet

Application Information

Application Type: Regular

Subject Matter: Utility

Suggested Classification:

Suggested Group Art Unit:

CD-ROM or CD-R?: None

Title: METHOD AND APPARATUS FOR REMOVING
WATER VAPOR AS A BYPRODUCT OF CHEMICAL
REACTION IN A WAFER PROCESSING CHAMBER

Request for Early Publication?: No

Request for Non-Publication?: Yes

Suggested Drawing Figure: 5

Total Drawing Sheets: 7

Small Entity: No

Petition included?: No

Secrecy Order in Parent Appl.?: No

Applicant Information

Applicant Authority type: Inventor

Primary Citizenship Country: USA

Status: Full Capacity

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Family Name: Broyles

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Applicant Information

Applicant Authority type: Inventor
Primary Citizenship Country: USA
Status: Full Capacity
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Correspondence Information

Correspondence Customer Number: 24319

Representative Information

Representative Customer Number:	24319
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Domestic Priority Information

Application::	Continuity Type:	Parent Application:	Parent Filing Date:
This application	Division of	10/140,536	05/07/2002

Assignee Information

Assignee name: LSI Logic Corporation

Street of mailing address: 1551 McCarthy Boulevard

City of mailing address: Milpitas

State or Province of
mailing address: California

Country of mailing address: USA

Postal or Zip Code of
mailing address: 95035